



PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the application of:

Kiermasz et al.

Application No: 10/607,613

Filed: June 27, 2003

For: PLATEN WITH DIAPHRAGM AND
METHOD FOR OPTIMIZING WAFER
POLISHING

Art Unit: 3723

Examiner: Rachuba, M.

Docket No: LAM2P421

Date: June 9, 2005

CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with the United States Postal Service as First Class Mail in an envelope addressed to: Commissioner for Patents, Alexandria, VA 22313-1450 on June 9, 2005.

Signed:

Kay Harlow

INFORMATION DISCLOSURE STATEMENT UNDER 37 CFR §§1.56 AND 1.97

Commissioner for Patents
Alexandria, VA 22313-1450

Dear Sir:

Enclosed is a PTO Form 1449 listing U.S. patents and foreign patents to be made of record. Applicant is hereby submitting copies of the cited foreign patents.

These references may be material to the examination of the above-identified patent application. Applicants submit this list of references in compliance with their duty of disclosure pursuant to 37 CFR §§1.56 and 1.97. The Examiner is requested to make these citations of official record in this application.

This Information Disclosure Statement is not to be construed as a representation that a search has been made, that additional information material to the examination of this application does not exist, or that these references indeed constitute prior art.

The fee of **\$180.00** as required in 37 C.F.R. § 1.17(p) is included with this transmittal. The Commissioner is authorized to charge any additional fees that may be due to our Deposit Account No. 50-0805 (Order No. LAM2P421). A duplicate copy of the transmittal is enclosed for this purpose.

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Respectfully submitted,
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Docket No: LAM2P421



Form 1449 (Modified) Information Disclosure Statement By Applicant (Use Several Sheets if Necessary)	Attorney Docket No: U.S. LAM2P421 10/607,613 Applicant: Kiermasz et al. Filing Date: Group: June 27, 2003 3723
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U.S. Patent Documents

Examiner Initial	No.	Patent No.	Date	Patentee	Class	Sub-class	Filing Date
	A	5,558,568	09/1996	Talieh et al.			
	B	5,593,344	01/1997	Weldon et al.			
	C	5,692,947	12/1997	Talieh et al.			
	D	5,722,877	03/1998	Meyer et al.			
	E	5,762,536	06/1998	Jairath et al.			
	F	6,086,456	04/2000	Weldon et al.			
	G	6,155,915	12/2000	Raeder			
	H	6,328,642	12/2001	Pant et al.			
	I	6,336,845	01/2002	Engdahl et al.			
	J	6,358,118	03/2002	Boehm et al.			
	K	6,712,679	03/2004	Taylor et al.			
	L	6,729,945	05/2005	Xu et al			

Foreign Patent or Published Foreign Patent Application

Examiner Initial	No.	Document No.	Publication Date	Country or Patent Office	Class	Sub-class	Translation	
							Yes	No
	M	CN1500028A	05/2004	CPO				x
	N	EP0706857	04/1996	EPO				
	O	EP0914906 A2	05/1999	EPO				
	P	WO0025982	05/2000	WIPO				
	Q	WO02078904	11/2002	WIPO			x	

Other Documents

Examiner Initial	No.	Author, Title, Date, Place (e.g. Journal) of Publication
Examiner		Date Considered

Examiner: Initial citation considered. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.